



PATENT

2/5/02
4/1/02
vs

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Yehiel et al.

Application No: 09/821,415

Filed: March 28, 2001

For: SEMICONDUCTOR STRUCTURE
IMPLEMENTING SACRIFICIAL MATERIAL AND
METHODS FOR MAKING AND IMPLEMENTING THE
SAME

Atty. Docket: LAM2P246

Examiner: H.K. Vu

Group Art Unit: 2811

Date: March 12, 2002

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on March 12, 2002.

Signed: _____

Kay Harlow
Kay Harlow

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

In response to the Restriction Requirement dated February 15, 2002, Applicants hereby elect, without traverse, Group I, claims 1-8, to prosecute in the above-identified Patent Application.

Should the Examiner have any questions concerning this matter, the undersigned can be reached at the telephone number set out below.

Respectfully submitted,
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